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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Confirmation No.: 3707

Yusuke MURAOKA, et al.

Date: May 9, 2005

Serial No.: 10/700,020

Group Art Unit: 1734

Filed: November 3, 2003

Examiner: Yewebdar T. Tadesse

For: SUBSTRATE PROCESSING METHOD, SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING SYSTEM

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

Supplemental to the Response to the Office Action filed on April 26, 2005, please
reconsider the above-identified application amended as follows.

SUMMARY OF AMENDMENTS

1. ☐ If checked, an abstract (an amended abstract) is submitted herewith.
2. ☐ If checked, amendment(s) to the drawings are submitted herewith.
3. ☐ If checked, amendment(s) to the specification are submitted herewith.
4. ☒ If checked, amendment(s) to the claims are submitted herewith.